

REPLY UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 1763

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION OF

Confirmation No.: 8174

Mitsuaki KOMINO *et al.*

Group Art Unit: 1763

Appln. No.: 09/667,770

Examiner: R. Zervigon

Filed: September 22, 2000

Title: PLASMA PROCESSING APPARATUS, AND ELECTRODE STRUCTURE AND  
TABLE STRUCTURE OF PROCESSING APPARATUS



September 29, 2003

\* \* \* \* \*

**AMENDMENT AFTER FINAL UNDER 37 C.F.R. § 1.116**

Hon. Commissioner of Patents  
Washington, D.C. 20231

Sir:

In response to the Office Action dated May 29, 2003, please amend the above  
identified application as follows:

10/01/2003 SSESHE1 00000172 033975 09667770  
01 FC:1202 18.00 DA